



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 25, 2026

IGI Report Number

LG805674734

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

12.36 X 6.10 X 3.67 MM

GRADING RESULTS

Carat Weight

1.55 CARAT

Color Grade

E

Clarity Grade

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

VERY GOOD

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG805674734

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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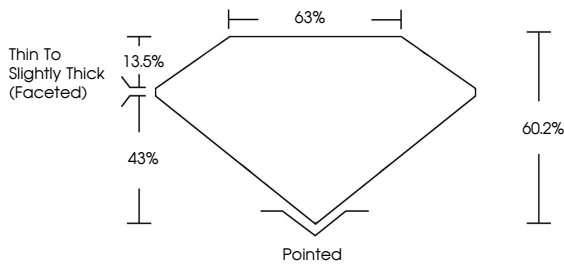
NONE

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PROPORTIONS



Thin To Slightly Thick (Faceted)

63%

13.5%

43%

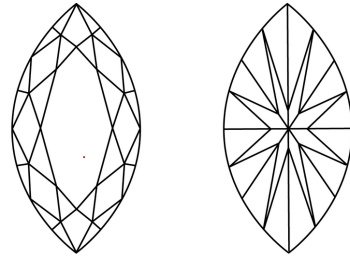
60.2%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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MARQUISE BRILLIANT

12.36 X 6.10 X 3.67 MM

Carat Weight

1.55 CARAT

Color Grade

E

Clarity Grade

VVS 1

Depth

60.2%

Table

63%

Girdle

Thin To Slightly Thick (Faceted)

Culet

Pointed

Polish

VERY GOOD

Symmetry

EXCELLENT

Fluorescence

NONE

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